



ELECTRONIC COPY

LABORATORY GROWN DIAMOND REPORT

LG828647455
Report verification at igi.org

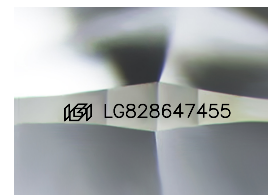
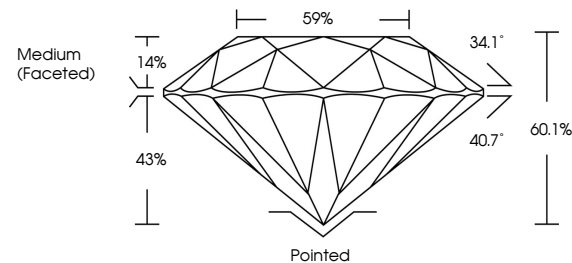
August 21, 2026	
IGI Report Number	LG828647455
Description	LABORATORY GROWN DIAMOND
Shape and Cutting Style	ROUND BRILLIANT
Measurements	6.52 - 6.56 X 3.93 MM
GRADING RESULTS	
Carat Weight	1.02 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL

ADDITIONAL GRADING INFORMATION

Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscription(s)	 LG828647455

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

PROPORTIONS



Sample Image Used

COLOR

D E F G H I J Faint Very Light Light

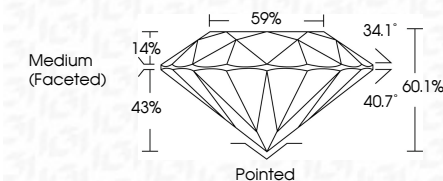
CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included

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August 21, 2026	
G Report No LG28267465	
ROUND BRILLIANT	
4.52 - 4.54 X 3.93 MM	
Carat Weight	1.02 CARAT
Color Grade	D
Clarity Grade	VVS 2
Cut Grade	IDEAL
Depth	60.1%
Table	85%
Girdle	Medium (Faceted)
Culet	Poished
Polish	EXCELLENT
Symmetry	EXCELLENT
Fluorescence	NONE
Inscriptions(s)	#61 LG28267465

Comments:

This Laboratory Grown Diamond was created by Chemical Vapor Deposition growth process.

Type IId